

DOCKET NO.: 288839US0PCT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

GROUP: 1715

Ekkehard MUEH, et al.

SERIAL NO: 10/586,675

EXAMINER: MILLER, JR, JOSEPH
ALBERT

FILED: July 20, 2006

FOR: SILICON COMPOUNDS FOR PRODUCING SiO₂-CONTAINING
INSULATING LAYERS ON CHIPS

RESTRICTION RESPONSE

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

Sir:

In response to the Restriction Requirement dated October 13, 2010, Applicants elect, with traverse, Group I, Claims 1-3 and 6 (drawn to process), for examination.

Applicants also provisionally elect, with traverse, for examination purposes only, the following species (at least claims 1-3 and 6 readable thereon):

A) vinyltrimethoxysilane; and

B) CVD.

Remarks/Arguments begin on page 2 of this paper.